



**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
PTO-1449

Sheet 1 of 2

Application No.: 10/522,638
Lodged: January 25, 2005
First Named Inventor: Richard SYMS
Art Unit: not assigned
Examiner Name: no assigned
Attorney Docket Number: 3599 P 010

U.S. PATENT DOCUMENTS

Examiner Initial	Document No. Kind Code (if known)	Name of Patentee or Applicant	Date (MM-DD-YYYY)
PJ	US 5,386,115 A	Freidhoff et al.	1/31/1995
PJ	US 5,401,962	Ferran	3/28/1995
PJ	US 5,719,393	Chutjian et al.	2/17/1998
PJ	US 6,025,591 A	Taylor et al.	2/15/2000
PJ	US 6,188,067	Shutjian et al.	2/13/2001

FOREIGN PATENT DOCUMENTS

Examiner Initial	Foreign Patent Document			Name of Patentee or Applicant	Date of Publication	T
	Office	Number	Kind			
PJ	PCT	WO97/47025		MDS, Inc.	12/11/1997	

OTHER PRIOR ART OR NON-PATENT LITERATURE DOCUMENTS

Examiner Initial	(including Author (in capital letters), Title of the article, Title of the item, Date, Pages, Volume-Issue number, Publisher, City and/or Country where published.)	T
PJ	J.J. Tunstall et al., "Silicon Micromachined Mass Filter for a Low Power, Low Cost Quadrupole Spectrometer," Micro Electro Mechanical Systems, 1998. Mems 98. Proceedings, the Eleventh Annual International Workshop on Heidelberg, Germany 25-29 Jan. 1998, New York, NY USA, IEEE, US, Pages 438-442.	
PJ	J.H. Batey, "Quadrupole Gas Analysers," Vacuum 37, 659-668 (1987)	

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
PTO-1449

Sheet 2 of 2

Application No.: 10/522,638
Lodged: January 25, 2005
First Named Inventor: Richard SYMS
Art Unit: not assigned
Examiner Name: no assigned
Attorney Docket Number: 3599 P 010

Examiner Signature: /Phillip Johnston/ (12/17/2006) Date Considered: _____

Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.